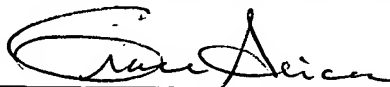


CERTIFICATE OF MAIL

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to the Commissioner for Patents and Trademarks, Washington, D.C. 20231, on May 17, 2002.



Grace Alicea

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Date: May 17, 2002

OKUDA, et al.

Serial No: 10/018,708

Group Art Unit: *to be assigned*

Filed: Dec. 13, 2001

Examiner: *to be assigned*

For: TABLE OF WAFER POLISHING APPARATUS, METHOD FOR POLISHING SEMICONDUCTOR WAFER, AND METHOD FOR MANUFACTURING SEMICONDUCTOR WAFER

Assistant Commissioner of Patents  
Washington, D.C. 20231

TRANSMITTAL LETTER

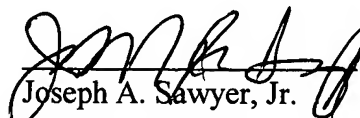
Sir:

In reference to the above-identified application, please find enclosed the following:

- 1) Information Disclosure Statement under 37 CFR 1.97(b);
- 2) PTO Form 1449 and four (4) references;
- 3) Transmittal Letter; and
- 4) Postcard.

If any unresolved issues remain, please contact Applicant's attorney at the telephone number indicated below.

Respectfully submitted,



Joseph A. Sawyer, Jr.  
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Attorney for Applicant  
Reg. No. 30,801  
(650) 493-4540



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